

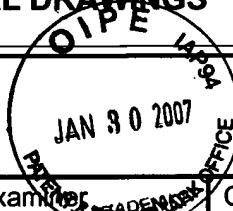
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TRANSMITTAL OF FORMAL DRAWINGS

Docket No.

BUR920040015US1 (17427)

In Re Application Of: Matthew J. Breitwisch



Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/710,821	August 5, 2004	Douglas W. Owens	23389	2811	6753

Invention: ISOLATED FULLY DEPLETED SILICION-ON-INSULATOR REGIONS BY SELECTIVE ETCH

Address to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith are:

3 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).



Signature

Dated: January 5, 2007

Steven Fischman  
Registration No. 34,594

SCULLY, SCOTT, MURPHY & PRESSER, P.C.  
400 Garden City Plaza, Suite 300  
Garden City, New York 11530  
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